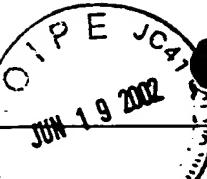


PATENT

Garnier-1



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Marcel GARNIER and Examiner: Ngoc-Yen M. Nguyen

Christian TRASSY

Serial No.: 09/582,049

Group Art Unit: 1754

Filed: September 18, 2000

For: **SILICON REFINING METHOD
AND INSTALLATION**

Date: June 13, 2002

Commissioner for Patents
Washington, D.C. 20231

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AMENDMENT AND RESPONSE TO OFFICE ACTION

Sir:

Responsive to the Office Action mailed March 13, 2002 which is due June 13, 2002,

please amend this application as follows:

IN THE CLAIMS

Kindly amend claim 9 as follows:

9. (TWICE AMENDED) A silicon refining installation comprising:
a cold inductive crucible (1) adapted to receiving the silicon;

B1